



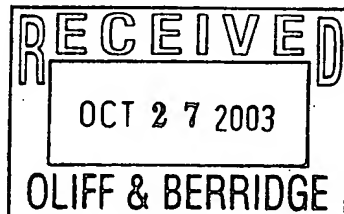
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10/629,777	07/30/2003	2828	972	116722	10	23	5

25944
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CONFIRMATION NO. 7916

FILING RECEIPT



OC000000011095205

Date Mailed: 10/24/2003

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Kanagawa
 Masahiro Yoshikawa, Ebina-shi, JAPAN;

Assignment For Published Patent Application

FUJI XEROX CO., LTD., Tokyo, JAPAN;

Domestic Priority data as claimed by applicant

Foreign Applications

JAPAN 2002-363484 12/16/2002

If Required, Foreign Filing License Granted: 10/23/2003

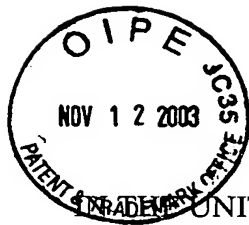
Projected Publication Date: To Be Determined - pending completion of Missing Parts

Non-Publication Request: No

Early Publication Request: No

Title

Method of forming conductive pattern such as electrode, surface emitting semiconductor laser
 using this method and manufacturing method for the same



PATENT APPLICATION

UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masahiro YOSHIKAWA

Application No.: 10/629,777

Docket No.: 116722

Filed: July 30, 2003

For: METHOD OF FORMING CONDUCTIVE PATTERN SUCH AS ELECTRODE,
SURFACE EMITTING SEMICONDUCTOR LASER USING THIS METHOD
AND MANUFACTURING METHOD FOR THE SAME

REQUEST FOR CORRECTION OF PALM RECORDS

Commissioner for Patents
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Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records. A Supplemental Application Data Sheet is attached.

Respectfully submitted,

James A. Oliff
Registration No. 27,075

Thomas J. Pardini
Registration No. 30,411

JAO:TJP/mlo

Date: November 12, 2003

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

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